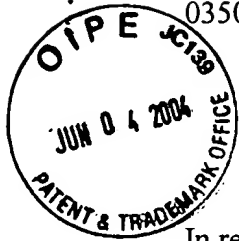


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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Luz L. Alejandro
NOBUMASA SUZUKI)	
	:	Group Art Unit: 1703
Application No.: 09/657,971)	
	:	
Filed: September 8, 2000)	
	:	
For: MICROWAVE PLASMA)	
PROCESSING APPARATUS	:	
AND METHOD THEREFOR)	June 2, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EXPRESS ABANDONMENT UNDER 37 C.F.R. §1.138
AND RETURN OF ORIGINAL GRANT OF LETTERS PATENT

Sir:

In accordance with Title 37 C.F.R. §1.138, the undersigned who is
authorized under 37 C.F.R. §1.33(b)(1) expressly abandons the subject reissue Application
No. 09/657,971, filed September 9, 2000, but not the invention disclosed therein.

Further, it is requested that the original grant of Letters Patent No.
5,803,975 which was surrendered in a surrender paper filed December 11, 2002 herein, be
returned to the undersigned.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicant

Registration No.

24987

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